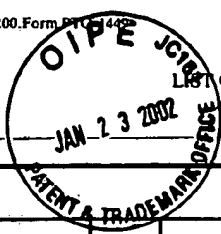


200 Form PTO-449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. M122-1208		SERIAL NO. 09/388,826	
<div style="text-align: center;">  <p>LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)</p> </div>				APPLICANT Weimin Li et al.			
				FILING DATE September 1, 1999		GROUP 2813	
U.S. PATENT DOCUMENTS							
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
EH	AA	5,801,399	9/98	Hattori et al.			
↑	AB	5,994,730	11/99	Shrivastava et al.			
	AC	6,040,619	3/00	Wang et al.			
	AD	6,060,765	5/00	Maeda			
↓	AE	6,060,766	5/00	Mehta et al.			
EH	AF	6,133,613	10/00	Yao et al.			
	AG						
	AH						
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EXAMINER <i>Em Km</i>	DATE CONSIDERED <i>1/29/04</i>
<p>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</p>	

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APPLY. DOCKET NO.
 M122-1208

SERIAL NO.
 09-352,826

APPLICANT
 Weimin (Michael) Li et al.

FILING DATE
 September 1, 1999

GROUP
 2813

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*Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
ELR	AA 6,087,064	07/20/00	Lin, et al.			
	AB					
	AC					
	AD					
	AE					
	AF					
	AG					
	AH					
	AI					
	AJ					

FOREIGN PATENT DOCUMENTS

	Document Number	Date	Country	Class	Subclass	Translation	
						Yes	No
	AK						
	AL						
	AM						
	AN						
	AO						
	AP						
	AQ						

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)

AR	Wolf et al., "Silicon Processing for the VLSI Era - Vol. 1 - Process Technology," Prologue, page xxiii (2 pages total).
AS	
AT	

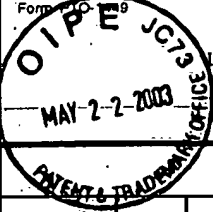
EXAMINER *En Km* DATE CONSIDERED *1/29/04*

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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Sheet 1 of 1

Form 10-99		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. M122-1208		SERIAL NO. 09/388,826		
 LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT Weimin Li, et al.				
				FILING DATE September 1, 1999		GROUP 2813		
U.S. PATENT DOCUMENTS								
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
Em	AA	4,755,478	07/05/1988	ABERNATHY, ET AL.	437	41		
Ek	AB	4,870,470	09/26/1989	BASS, JR., ET AL.	357	23.5		
Ek	AC	5,312,768	05/17/1994	GONZALEZ	437	40		
Ek	AD	5,439,838	08/08/1995	YANG	437	43		
	AE							
	AF							
	AG							
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FOREIGN PATENT DOCUMENTS								
		Document Number	Date	Country	Class	Subclass	Translation	
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	AO							
	AP							
	AQ							
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)								
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	AT							
EXAMINER <i>Em</i>				DATE CONSIDERED <i>1/29/04</i>				
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.								

Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. M122-1208		SERIAL NO. 09/388,826	
<div style="display: flex; align-items: center; justify-content: center;"> <div style="border: 1px solid black; border-radius: 50%; padding: 10px; text-align: center; margin-right: 10px;"> OIPE SEP 16 2003 PATENT & TRADEMARK OFFICE </div> <div> LIST OF ART CITED BY APPLICANT (Use several sheets if necessary) </div> </div>				APPLICANT Weimin Li, et al.		FILING DATE September 1, 1999	
				GROUP 2813			
U.S. PATENT DOCUMENTS							
*Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
En	AA 6518122	02/2003	Chan et al			<div style="font-size: 4em; transform: rotate(45deg);">X</div>	
↑	AB 6492688	12/2002	Ilg				
	AC 6373114	04/2002	Jeng et al				
	AD 2001/0019868	09/2001	Gonzalez et al				
	AE 2001/0003064	06/2001	Ohno				
En	AF 2003/0013311	01/2003	Chang et al				
	AG						
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	AK						
	AL						
FOREIGN PATENT DOCUMENTS							
	Document Number	Date	Country	Class	Subclass	Translation	
						Yes	No
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	AO						
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OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)							
	AR						
	AS						
	AT						
EXAMINER			DATE CONSIDERED				
En			1/29/04				
<small>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</small>							

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